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	Application No.	Applicant(s)	
Nation of Allowahility	09/881,408	AHN ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Thao X. Le	2814	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject t	pplication. If not included n will be mailed in due co	ourse. THIS
1. This communication is responsive to <u>08/31/05</u> .			
2.  The allowed claim(s) is/are <u>1-19,56-58 and 62</u> .			
3. $\boxtimes$ The drawings filed on <u>13 June 2001</u> are accepted by the E	xaminer.		
<ul> <li>4. Acknowledgment is made of a claim for foreign priority una)</li> <li>All b) Some* c) None of the:</li> <li>1. Certified copies of the priority documents have</li> <li>2. Certified copies of the priority documents have</li> <li>3. Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	been received. been received in Application No	·	on from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requ	irements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			TICE OF
6. CORRECTED DRAWINGS ( as "replacement sheets") mus	t be submitted.		
(a) 🔲 including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO	-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b)  including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the G	Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the	.84(c)) should be written on the drawing he header according to 37 CFR 1.121	ings in the front (not the b	ack) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERIAL	must be submitted. No	te the
Attachment(s)  1. ☐ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	5. ☐ Notice of Informal f	(PTO-413),	152)
3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Da 8), 7. Examiner's Amend	ate ment/Comment	
Paper No./Mail Date <u>11/23/05</u>	_		
4. Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Statem	ent of Reasons for Allow	ance
of Biological Material	9.		

## Allowable Subject Matter

1. The following is a statement of reasons for the indication of allowable subject matter:

- a. Claims 1-2, 6-19 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims. The prior art of record neither anticipated not rendered obvious the limitation 'forming a second metal-containing layer on and in contact with the first metal-containing layer, all the metal of the second layer consisting of at least one element selected from Group IIIB of the periodic table; exposing the first layer and the second layer to an oxygen comprising atmosphere and heating the first laver and the second layer to a temperature effective to form a first metal-containing-dielectric layer consisting of metal oxide and a second metal-containing dielectric layer consisting of metal oxide'.
- b. Claims 3-5 and 62 are allowed because the prior art of record neither anticipated nor rendered obvious all the limitations of the base claim 3 including heating the metal layer and layer of silicon dioxide to a temperature of from about 200°C to less than 400°C and combining metal of the metal layer with oxygen of the silicon dioxide layer to form a metal oxide dielectric material comprised by a first metal containing dielectric layer over the substrate, all the metal of me first dielectric layer consisting of at least one element selected from Group IVB of the

Art Unit: 2814

periodic table; and forming a second metal-containing dielectric layer on and in contact with the first metal-containing dielectric layer, all the metal of the second dielectric layer consisting of at least one element selected from Group IIIB of the periodic table.

- c. Claims 56-57 are allowed because the prior art of record neither anticipated not rendered obvious at the limitations of the base claim 56 including exposing the hafnium-containing layer and the lanthanum layer to an oxygen comprising atmosphere by ion bombardment using an ion bombardment energy of about 10 electron volts (eV) or less, and heating the hafnium-containing layer and the lanthanum layer to a temperature effective to form a hafnium-containing dielectric layer and a lanthanum-containing dielectric layer.
- d. Claim 58 is allowed because the prior art of record neither anticipated not rendered obvious at the limitations of the base claim 58 including forming a layer of silicon dioxide overlying at least one portion of the surface; forming a hafnium-containing layer over the layer of silicon dioxide; combining hafnium of the hafnium-containing layer with oxygen of the silicon dioxide layer to form a hafnium oxide over the surface; forming a lanthanum-containing layer over the hafnium-containing layer and positioning the substrate within a reaction chamber and exposing the hafnium-containing layer and the lanthanum-containing layer to oxygen radicals within the reaction chamber and heating the hafnium-containing layer and the lanthanum-containing layer to a temperature effective to form a hafnium-containing dielectric layer and a lanthanum-containing dielectric layer.

Art Unit: 2814

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao X. Le whose telephone number is (571) 272-1708. The examiner can normally be reached on M-F from 8:00 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael M. Fahmy can be reached on (571) 272 -1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thao X. Le 07 December 2005